IN THE UNITED STATES PATENT AND TRADEMARK OFFICE DEC 1 2 2003

Group Art Unit: 2812

Examiner: Not yet assigned

TENT APPLICATION Of:

Applicants:

Noriko TOMITA et al.

Serial No.:

10/660,490

Filed:

September 12, 2003

For:

SEMICONDUCTOR SUBSTRATE

SURFACE PROTECTION METHOD

Docket No.:

OHG-135

December 12, 2003

INFORMATION **DISCLOSURE**

STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b) (1) and (b)(3), i.e., within three months from the filing of the application and prior to a First Office Action on the Merits.

Attached is a copy of a Japanese publication. Any relevance of this publication can be gleaned from the corresponding cited U.S. patent. The documents are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed before the First Office Action, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to all documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted

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RHB:crh

FEE ENCLOSED:\$ $\mathscr D$ Pleas charge any further fee to our Deposit Account No. 18-0002

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty. Docket: OHG-125	Application No.: 10/660,490		
© IPE CONT				Applicant: Noriko TOMITA et al.			
DEC 1 2 2003 BY TRADEMINE U.S. PATE				Filing Date: September 12, 2003	Group Art Unit: 2812		
- V	PADE	MAT	NT DOCUMENTS	<u> </u>			
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date
	AA	6,165,956	12/26/00	Zhang et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	АН						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub- Class	Trans - lation
	Al	2001-521285	06/11/01	Japan			No
	AJ						
	AK						
	AL						
	AM						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AN						
	AO						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							